

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Van Der Feltz *et al.*

Appl. No.: 10/811,070

Filed: March 29, 2004

For: **Lithographic Apparatus and  
Device Manufacturing Method**

Confirmation No.: 8087

Art Unit: 2851

Examiner: Peter B. Kim

Atty. Docket: 1857.2780000

**Submission Under 37 C.F.R. § 1.114(c)**

*Mail Stop RCE*

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

The claims have been amended in response to the outstanding Office Action dated September 5, 2006. To ensure consideration of the amended claims and to further expedite prosecution, a Request for Continued Examination (RCE) is concurrently submitted herewith. Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks and Arguments begin on page 11 of this paper.

It is not believed that extensions of time or fees for net addition of claims are required beyond those that may otherwise be provided for in documents accompanying this paper. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No. 19-0036.